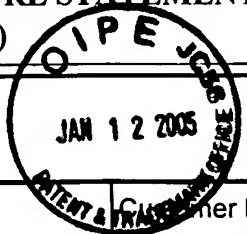


TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT (Under 37 CFR 1.97(b) or 1.97(c))				Docket No. YOU101	
In Re Application Of: Kim, et al.					
Application No.	Filing Date	Examiner	Customer No.	Group Art Unit	Confirmation No.
10/786,340	February 25, 2004		32047	1762	4561
Title: METHOD OF IMPROVING THE PERFORMANCE OF ORGANIC COATINGS FOR CORROSION RESISTANCE					
Address to: Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450					
37 CFR 1.97(b)					
1. <input checked="" type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.					
37 CFR 1.97(c)					
2. <input type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:					
<div style="margin-left: 40px;"> <input type="checkbox"/> the statement specified in 37 CFR 1.97(e); </div>					
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In Re Application: Kim, et al.						
Application No.	Filing Date	Examiner	Class. Officer No.	Group Art Unit	Confirmation No.	
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Title: METHOD OF IMPROVING THE PERFORMANCE OF ORGANIC COATINGS FOR CORROSION RESISTANCE						



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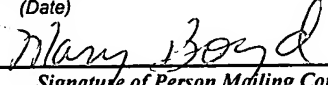
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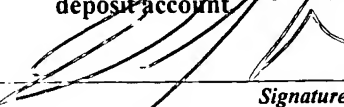
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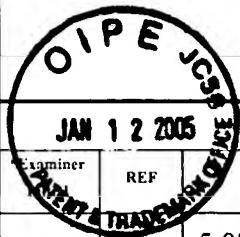
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Donald J. Perreault
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 55 South Commercial Street
 Manchester, NH 03101
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Dated: **January 10, 2005**

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YOU101

Application No.

10/786,340

Applicants(s)

Kim et al.

Filing Date

February 25, 2004

Group Art Unit

1762

U.S. PATENT DOCUMENTS

Examiner	REF	DOCUMENT NUMBER	DATE	NAME	CLASS/SUBCLASS	FILING DATE IF APPROPRIATE
		5,077,354	12/31/1991	Woo et al.	528/26	
		5,389,405	02/14/1995	Purnell et al.	427/387	
		5,412,011	05/02/1995	Morris et al.	524/261	
		5,455,080	10/03/1995	van Ooij	427/470	
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		6,607,587 B1	08/19/2003	Kanai et al.	106/14.44	

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REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS/SUBCLASS	TRANSLATION	
					YES	NO
	EP1002889 A2	05/24/2000	EPO	C23C/22/68		

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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YOU101

Application No.

10/786,340

Applicants(s)

Kim et al.

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Group Art Unit

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